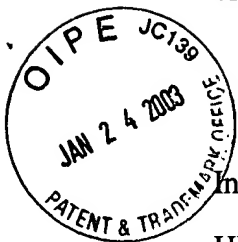


03500.015293

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

HIDEO KITAGAWA ET AL.

Application No.: 09/832,978

Filed: April 12, 2001

For: METHOD OF ETCHING
ORGANIC FILM AND METHOD
OF PRODUCING ELEMENT

Examiner: A. Olsen

Group Art Unit: 1763

January 23, 2003

Commissioner for Patents
Washington, D.C. 20231

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TECHNOLOGY CENTER 1100

AMENDMENT AND PETITION FOR EXTENSION OF TIME

Sir:

I. Applicants petition to extend the time for response to the Office Action dated September 25, 2002 for one month from December 25, 2002 to January 25, 2003. A check in the amount of \$110.00 for payment of the extension fee is enclosed. Please charge any additional fee required for the extension, and credit any overpayment, to Deposit Account 06-1205.

II. In response to the Office Action dated September 25, 2002, the period for reply having been extended by the above petition and payment of the extension fee, please consider the following remarks.

IN THE SPECIFICATION:

Please replace the paragraph beginning on page 3, line 1, and ending on page 3, line 10, with the following paragraph. A marked-up copy of the original paragraph, showing the changes made thereto, is attached.